

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Justin K. Brask et al.

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Art Unit: 2811

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Serial No.: 10/622,955

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Examiner: Sara W. Crane

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Filed: July 18, 2003

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For: Etching Metal Silicides
and Germanides

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Atty Docket: ITL.1021US
P16708

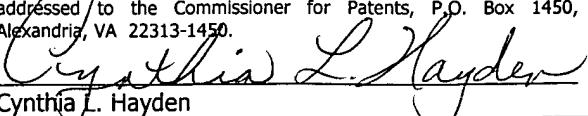
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement mailed October 6, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: <u>October 14, 2004</u>
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden